

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

EL 465780496

Priority Application Serial No. 09/030,618
Priority Filing Date February 25, 1998
Inventor Richard Holscher et al.
Assignee Micron Technology, Inc.
Priority Group Art Unit 1756
Priority Examiner K. Duda
Attorney's Docket No. MI22-1694
Title: Semiconductor Processing Methods

INFORMATION DISCLOSURE STATEMENT

References -- See Attached Form PTO-1449


The attached form PTO-1449 is submitted in compliance with 37 CFR §1.56. No admission is made regarding whether the submitted references are prior art.

The listed references were cited by, or submitted to, the Office in the parent, co-pending application of the above-identified application. The above-identified application is a continuation of co-pending Application Serial No. 09/030,618, filed on February 25, 1998. Such prior disclosure is sufficient for the above-identified application as far as copies of the references are concerned.

Citation of these references is respectfully requested.

Respectfully submitted,

Dated: 6-19-01

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